



35.C15334

PATENT APPLICATION

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of:

KAZUYA ISHIWATA ET AL.

Application No.: N.Y.A.

Filed: May 2, 2001

For: ELECTRON SOURCE FORMING  
SUBSTRATE, ELECTRON  
SOURCE USING THE  
SUBSTRATE, AND IMAGE  
DISPLAY APPARATUS

Examiner: Not Yet Assigned

Group Art Unit: N.Y.A.

August 23, 2001

Commissioner of Patents  
Washington, D.C. 20231

#1120,  
mk  
5/22/03

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INFORMATION DISCLOSURE STATEMENT

Sir:

In compliance with the duty of disclosure under 37 C.F.R. § 1.56 and in accordance with the practice under 37 C.F.R. §§ 1.97 and 1.98, the Examiner's attention is directed to the documents listed on the enclosed Form PTO-1449. A copy of each listed document is also enclosed.

The concise explanation of relevance for the listed Japanese document may be found in its English-language abstract, submitted herewith, and in the specification at page 3, where this reference is cited. The explanation of relevance for the listed Japanese-language article may be found in its counterpart U.S. Patent, submitted herewith, and in the specification at page 2, where this reference is cited.

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The Examiner's attention is also directed to the following U.S. Applications:

<u>APPLICATION NO.</u>	<u>FILING DATE</u>	<u>GROUP ART UNIT</u>
09/847,420	05/03/01	NYA
09/845,286	05/01/01	2879

A copy of each cited Application, as originally filed, is enclosed.

CONCLUSION

It is respectfully requested that the above information be considered by the Examiner and that a copy of the enclosed Form PTO-1449 be returned indicating that such information has been considered.

Applicants' undersigned attorney may be reached in our New York office by telephone at (212) 218-2100. All correspondence should continue to be directed to our address given below.

Respectfully submitted,

  
Attorney for Applicants

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